

Corres. and Mail BOX AF

11/2700

C.B-

RESPONSE UNDER 37 CFR 1.116 EXPEDITED PROCEDURE EXAMINING GROUP 2125

00862.022199.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: P. L. Rodriguez
Keiji EMOTO)	
	:	Group Art Unit: 2125
Application No.: 09/833,766)	
Til 1 4 1140 0004	:	Confirmation No.: 4154
Filed: April 13, 2001)	
For: PIPE STRUCTURE, ALIGNMENT APPARATUS,)	April 2, 2004
ELECTRON BEAM LITHOGRAPHY	:	
APPARATUS, EXPOSURE APPARATUS,)	RECEIVED
EXPOSURE APPARATUS MAINTENANCE	:	-
METHOD, SEMICONDUCTOR DEVICE)	APR 0 7 2004
MANUFACTURING METHOD, AND SEMI-	:	Technology Center 2100
CONDUCTOR MANUFACTURING FACTORY)	recimology denter 2100

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action dated February 5, 2004, please amend the above-identified application as follows pursuant to 37 C.F.R. § 1.116:

tofoeth

Entry Not Recommended

EN AKE